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PTO/SB/08A (08-00)

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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number	09/843,563
Filing Date	April 26, 2001
First Named Inventor	Mark A. Lucak
Group Art Unit	2812
Examiner Name	--
Attorney Docket Number	00AB179

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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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Examiner
Signature

William D. Al

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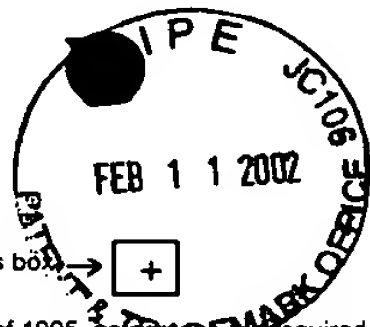
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449B/PTO		Complete if Known			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	09/843,563		
		Filing Date	April 26, 2001		
		First Named Inventor	Mark A. Lucak		
		Group Art Unit	2812		
		Examiner Name			
Sheet	2	of	4	Attorney Docket Number	110003.97427

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	1	Toumazou, C. et al., n-step Charge Injection Cancellation Scheme for Very Accurate Switched Current Circuits, Electronic Letters, V.30 (9) 680-681: 1994.	
	2	Emmerich, H., et al., A Novel Micromachined Magnetic-Field Sensor, MEMS 99 IEEE Conference, January 17-21, 1999, IEEE Catalog No. 99ch36291c.	
	3	Madou, Marc, Fundamentals of Microfabrication, Chapters 2-4, CRC Press LLC, Boca Raton, FL: 1997.	
	4	Kovacs, Gregory T.A., Micromachined Transducers Sourcebook, Table of Contents, pp. 77-119 and Index, WCB McGraw-Hill, U.S.A.: 1998.	
	5	Teegarden, Darrell et al., How to Model and Simulate Microgyroscope Systems, IEEE Spectrum, 66-75, July 1998.	
	6	Emmerich, Harald et al., Magnetic Field Measurements with a Novel Surface Micromachined Magnetic-Field Sensor, IEEE Transactions on Electron Devices, V. 47 (5) 972-977, May 2000.	
	7	McGruer, N.E. et al., Electrostatically Actuated Microswitches; Scaling Properties, Solid-State Sensor and Actuator Workshop, Hilton Head Island, South Carolina, June 8-11, 1998, pp.132-135.	
	8	Miyajima, Hiroshi et al., High-Aspect-Ratio Photolithography for MEMS Applications, J. of Microelectromechanical Sys., V.4(4) 220-229, Dec. 1995.	
	9	Lu, Crist et al., A Monolithic Surface Micromachined Accelerometer with Digital Output, IEEE J. of Solid State Circuits, V. 30 (12) 1367-1373, Dec. 1995.	
	10	Chen, Ming-Jer et al., Weak Inversion Charge Injection in Analog MOS Switches, IEEE J. of Solid-State Circuits, V. 30 (5) 604-606, May 1995.	
	11	Lemkin, Mark A. et al., A Fully Differential Lateral S ² Accelerometer with Drift Cancellation Circuitry, Solid-State Sensor and Actuator Workshop, Hilton Head, South Carolina, June 2-6, 1996, pp. 90-93.	

Examiner Signature		Date Considered	7/11/03
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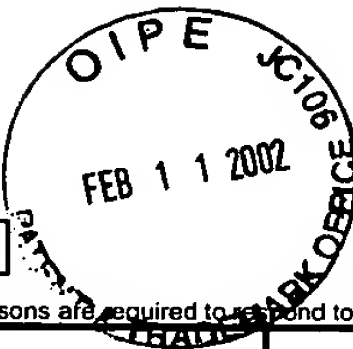
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 4 of 4

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Application Number	09/843,563
Filing Date	April 26, 2001
First Named Inventor	Mark A. Lucak
Group Art Unit	2812
Examiner Name	
Attorney Docket Number	110003.97427

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
aw	1	U.S. Patent Application No.: 09/406,654, filed on September 27, 1999.	
aw	2	U.S. Patent Application No.: 09/400,125, filed on September 21, 1999.	
aw	3	U.S. Patent Application No.: 09/406,509, filed on September 28, 1999.	
aw	4	U.S. Patent Application No.: 09/955,493, filed on September 18, 2001.	
aw	5	U. S. Patent Application No.: 09/955,494, filed on September 18, 2001.	
aw	6	U.S. Patent Application No.: 09/675,861, filed on September 29, 2000.	

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